EAST Search History (Prior Art)

| Ref # | Hits | Search Query | DBs | Defa ult Oper ator | Plurals | Time Stamp |
|----------|------|---|--|-----------------------------|---------|------------------|
| L1 | 3 | "20030079764" | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | AND | ON | 2010/02/19 09:45 |
| L3 | 3335 | (134/94.1,95.1,95.2,95.3,144,157).CCLS. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2010/02/19 12:36 |
| L4 | 918 | I3 and (semiconductor or wafer or substrate) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | AND | ON | 2010/02/19 12:43 |
| L8 | 300 | I4 and nozzle mix\$3 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | AND | ON | 2010/02/19 12:46 |
| L9 | 71 | I4 and nozzle mix\$3 near6 gas\$4 near7 (liquid or water) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | AND | ON | 2010/02/19 12:46 |
| L11 | 33 | I4 and nozzle near10 mix\$3 near6 gas\$4 near7 (liquid or water) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | AND | ON | 2010/02/19 12:47 |